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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/496,794 02/02/2000		John T. Moore	MICT-0005-D1-US	6700	
7	590 04/09/2003				
Trop Pruner & Hu			EXAMINER		
8554 Katy Freeway Suite 100			OWENS, DOUGLAS W		
Houston, TX	77024		ART UNIT	PAPER NUMBER	
			2811	2811	
			DATE MAILED: 04/09/2003		

Please find below and/or attached an Office communication concerning this application or proceeding.

Office Action Summary		Application No.	Applicant(s)				
		09/496,794	MOORE ET AL.				
		Examiner	Art Unit				
		Douglas W Owens	2811				
Period 1	The MAILING DATE of this communication app for Reply	ears on the cover sheet with the c	orrespondence address				
THE - Ext afte - If th - If N - Fai - Any	HORTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. ensions of time may be available under the provisions of 37 CFR 1.13 or SIX (6) MONTHS from the mailing date of this communication. he period for reply specified above is less than thirty (30) days, a reply 10 period for reply is specified above, the maximum statutory period was lure to reply within the set or extended period for reply will, by statute, or reply received by the Office later than three months after the mailing med patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be time within the statutory minimum of thirty (30) day will apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).				
1)⊠	Responsive to communication(s) filed on 21 J	anuary 2003 .					
2a)[_	This action is FINAL . 2b)⊠ Thi	s action is non-final.					
3)[
Disposi	closed in accordance with the practice under to tion of Claims	=x parte Quayre, 1955 C.D. 11, 4	55 O.G. 215.				
4)⊠	Claim(s) <u>26-30</u> is/are pending in the application	n.					
	4a) Of the above claim(s) is/are withdrawn from consideration.						
5)[_	Claim(s) is/are allowed.						
6)⊠	6)⊠ Claim(s) <u>26-30</u> is/are rejected.						
7)	Claim(s) is/are objected to.						
	Claim(s) are subject to restriction and/or	election requirement.					
Application Papers							
9) The specification is objected to by the Examiner.							
10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.							
Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a). 11) The proposed drawing correction filed on is: a) approved b) disapproved by the Examiner.							
If approved, corrected drawings are required in reply to this Office action.							
12) The oath or declaration is objected to by the Examiner.							
Priority under 35 U.S.C. §§ 119 and 120							
13) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).							
a) ☐ All b) ☐ Some * c) ☐ None of:							
1. Certified copies of the priority documents have been received.							
2. Certified copies of the priority documents have been received in Application No							
 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 							
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).							
 a) The translation of the foreign language provisional application has been received. 15) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121. 							
Attachme	nt(s)						
2) 🔲 Noti	ce of References Cited (PTO-892) ce of Draftsperson's Patent Drawing Review (PTO-948) rmation Disclosure Statement(s) (PTO-1449) Paper No(s)	5) Notice of Informal F	(PTO-413) Paper No(s) Patent Application (PTO-152)				

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DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 26 30 are rejected under 35 U.S.C. 103(a) as being unpatentable over US patent No. 5,940,716 to Jin et al.

Regarding claims 26, 28 and 30 Jin et al. teaches a semiconductor structure (Fig.

15 - 24), comprising:

5,940,716

a support (200);

a first material (206) deposited on the support (Col. 6, lines 62 – 66), the first material having a first etch rate;

a trench (209) formed through the first material and into the support; and a trench filler material (210A) deposited in the trench.

Jin et al. does not explicitly teach a trench filler material having an etch rate that is less than 1.2 times the first etch rate. Jin et al. teaches a filler material comprising CVD silicon dioxide (Col. 6, lines 21 - 26). Jin et al. teaches a first material that is deposited, but is silent with respect to the method of deposition. One having ordinary skill in the art would have been required to select a known oxide material. CVD silicon dioxide is a known oxide that is well suited for the intended use. It would have been obvious to one having ordinary skill in the art to select CVD silicon dioxide, since it is a

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known material that is well suited for the intended use. CVD silicon dioxide would have had an etch rate that is less than 1.2 times the etch rate of CVD silicon dioxide.

Jin et al. Further teaches removing the first material and a portion of the trench filler material (Figs. 20 – 21). Jin et al. does not explicitly teach etching the materials simultaneously. This is considered a product-by-process limitation. "Even though product-by-process claims are limited by and defined by the process, determination of patentability is based on the product itself. The patentability of a product does not depend on its method of production. If the product in the product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product was made by a different process." In re Thorpe, 777 F.2d 695, 698, 227 USPQ 964, 966 (Fed. Cir. 1985).

Regarding claims 27 and 29 Jin et al. does not teach a semiconductor device, wherein the first material and the trench filler material includes silicon dioxide deposited by chemical vapor deposition from TEOS or a silane and oxygen system. TEOS and silane and oxygen systems are conventional methods of depositing silicon dioxide. It would have been obvious to select either method because they are established delivery systems of silicon dioxide and arriving at new methods would result in additional costs of manufacturing because of additional research and development. Furthermore, this is considered a product-by-process limitation, as discussed above.

Response to Arguments

3. Applicant's arguments with respect to claims 26 – 30 have been considered but are most in view of the new ground(s) of rejection.

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Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Douglas W Owens whose telephone number is 703-308-6167. The examiner can normally be reached on Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Tom Thomas can be reached on 703-308-2772. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-308-7722 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

DWO April 4, 2003

Stevendoke